

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Heng Liu
Title: Chemical Vapor Deposition Reactor
Application No.: 10/621,049 Filing Date: July 15, 2003
Examiner: Kackar, Ram N. Group Art Unit: 1763
Docket No.: M-15626 US Confirmation No. 8846


Irvine, California
May 24, 2005

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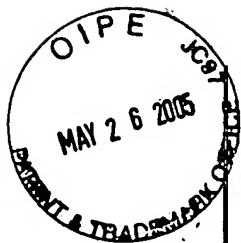
Dated: May 24, 2005


Monique M. Butler

MacPherson Kwok Chen & Heid LLP
1762 Technology Drive
Suite 226
San Jose, California 95110
Telephone: (949) 752-7040
Fax: (408) 392-9262

LAW OFFICES OF
MACPHERSON KWOK CHEN
& HEID LLP

1762 TECHNOLOGY DRIVE
SUITE 226
SAN JOSE, CA 95110
(949) 752-7040
FAX (408) 392-9262



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**INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §1.56**

Sir:

It is requested that the information identified in this statement be considered by the Examiner and made of record in the above-identified application. This statement is not intended to be an admission that the documents cited herein are necessarily prior art with respect to the instant invention, a representation that a search has been made, or that the information cited in the statement is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56.

Enclosed with this statement are the following:

- ☒ Form PTO/SB/08A and/or PTO/SB/08B. The Examiner is requested to initial the form and return it to the undersigned in accordance with M.P.E.P. §609.
- ☒ A copy of each cited non-U.S. document as required by 37 C.F.R. §1.98 (*except where otherwise indicated for a specific citation*).
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- ☒ The Commissioner is authorized to deduct \$180.00 from the undersigned's Deposit Account No. 50-2257. Please deduct any additional fees from, or credit any overpayment to the above-noted Deposit Account.

MacPherson, Kwok, Chen &
Heid LLP
1762 Technology Drive
Suite 226
San Jose, CA 95110
Telephone (949) 752-7040
Fax (408) 392-9262

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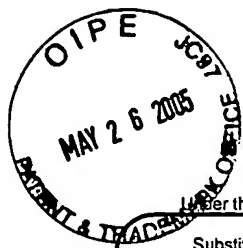
May 24, 2005
Date of Signature

Respectfully submitted,

Norman E. Carte
Attorney for Applicants
Reg. No. 30,455

Appln. No. 10/621,049

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PTO/SB/08A (08-03)

Approved for use through 07/31/2006. OMB 0651-0031

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STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet 1

of 1

Complete if Known

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|------------------------|------------------|
| Application Number | 10/621,049 |
| Filing Date | July 15, 2003 |
| First Named Inventor | Heng Liu |
| Art Unit | 1763 |
| Examiner Name | Not Yet Assigned |
| Attorney Docket Number | M-15626 US |

U. S. PATENT DOCUMENTS

| Examiner Initials* | Cite No. ¹ | Document Number | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
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FOREIGN PATENT DOCUMENTS

| Examiner Initials* | Cite No. ¹ | Foreign Patent Document | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear | T ⁶ |
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This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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